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CONFIRMATION NO. 9508

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|-----------------------------|---------------------------------------|--------------|------------------------|---|
| SERIAL NUMBER 10/646,405 | FILING DATE 08/22/2003 RULE | CLASS 204 | GROUP ART UNIT 1753 | ATTORNEY DOCKET NO. AMAT/3177.D1/CPI/L/B/PJS |
|-----------------------------|---------------------------------------|--------------|------------------------|---|

APPLICANTS

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** CONTINUING DATA *****

This application is a DIV of 09/505,263 02/16/2000 PAT 6,627,056 

** FOREIGN APPLICATIONS *****



IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/13/2003

| Foreign Priority claimed | <input type="checkbox"/> yes <input checked="" type="checkbox"/> no | STATE OR | SHEETS | TOTAL | INDEPENDENT |
|---------------------------------|---|----------|---------|--------|-------------|
| 35 USC 119 (a-d) conditions met | <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | COUNTRY | DRAWING | CLAIMS | CLAIMS |
| Verified and Acknowledged |  Initials | CA | 4 | 32 | 4 |

ADDRESS

44257
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TITLE

Method and apparatus for ionized plasma deposition

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| FILING FEE | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) |
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- 1.18 Fees (Issue)
- Other _____
- Credit